

EXHIBIT A

# Intellectual Property Law Department

LSI LOGIC®

## Authorization

Preparation and filing of original U.S.  
patent application in USPTO

1551 McCarthy Blvd.  
Milpitas, CA 95035

Ph: 408/433-8708, Fax: 408/433-7770, MS D-106, Email: mkovacs@lsil.com

### Via Fax

Date : Wednesday, September 08, 1999

John P. Taylor

TAYLOR, JOHN

P.O. Box 1598

Temecula, CA, 92593-1598 USA

RECEIVED SEP 08 1999  
Via Fax

Due Date - to receive first draft

Monday, November 15, 1999

Title : Application of Remote Nitrogen Plasmas to Controllably Etch Gate Oxide

Docket No. : 99-039

Your Docket No.

LSI Attorney : Ralph Vesell, Ph: 408/433-6404, MS D-106

Paralegal : Maria Kovacs, Ph: 408/433-8708, MS D-106

Dear Mr. John P. Taylor,

This is an authorization for the following task for the above identified application in accordance with our directions - Preparation and filing of original U.S. patent application in USPTO.

The billing code for the task is :

4P-USP

The maximum authorized amount for the task is :

\$5,500.00

As always, thank you very much for your assistance.

Very truly yours,

Maria Kovacs, Ph: 408/433-8708, MS D-106 mkovacs@lsil.com

Intellectual Property Paralegal

cc : Ralph Veseli, Ph: 408/433-6404, MS D-106

9/9/99 8:45A Please Note:  
per MPK ~~START~~ START  
via tel. ~~DATE~~ DATE OCT. 4, '99

Wednesday, September 08, 1999

1999-09-08 16:06 #805 P.01/08

408 433 7770

Page 1 of 1

FROM: LSI LOGIC-LEGAL

BEST AVAILABLE COPY